

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/894,125

Filed: June 29, 2001

For: CRYSTALLINE SEMICONDUCTOR
THIN FILM, METHOD OF
FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SAME

) Group Art Unit: 2823

) Examiner: B. Kebede

CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
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P.O. Box 1450, Alexandria, VA 22313-1450, on
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Rose G. Clark

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

Further in response to the Official Action dated May 21, 2003, please consider
the following amendments and remarks in connection with the above-identified
application.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 10 of this paper.